PATENT ASSIGNMENT COVER SHEET

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EPAS ID: PAT6787349

SUBMISSION TYPE:	NEW ASSIGNMENT
NATURE OF CONVEYANCE:	ASSIGNMENT

CONVEYING PARTY DATA

Name	Execution Date
DANIEL DAVID HARRISON	02/24/2021
GE WANG	02/24/2021

RECEIVING PARTY DATA

Name:	RENSSELAER POLYTECHNIC INSTITUTE
Street Address:	110 8TH STREET
Internal Address:	J BUILDING
City:	TROY
State/Country:	NEW YORK
Postal Code:	12180

PROPERTY NUMBERS Total: 1

Property Type	Number
Application Number:	17354286

CORRESPONDENCE DATA

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ATTORNEY DOCKET NUMBER:	104225-301	
IAME OF SUBMITTER: STEPHEN N. KULHANEK		
SIGNATURE:	/Stephen N. Kulhanek/	
DATE SIGNED: 06/29/2021		
	This document serves as an Oath/Declaration (37 CFR 1.63).	

Total Attachments: 3

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ASSIGNMENT

WHEREAS, We, Daniel David Harrison, residing at 583 Lake Road, Delanson, NY 12053, and Ge Wang, residing at 20 Hilander Drive, Loudonville, NY 12211, have invented certain new and useful improvements in FILTRATION METHODS FOR DUAL-ENERGY X-RAY CT ("the Invention") for which we:

have executed or authorized the execution of an application for Letters Patent of the United States of even date herewith;

have filed or authorized the filing of an application for Letters Patent of the United States on March 6, 2019 under Serial No. 16/294,438; and

WHEREAS, The above-identified application was made or authorized to be made by us. We believe that we are the original inventor or an original joint inventor of a claimed invention in the application and hereby acknowledge that any willful false statement made in this declaration is punishable under 18 U.S.C. 1001 by fine or imprisonment of not more than five (5) years, or both;

WHEREAS, Rensselaer Polytechnic Institute, organized under the laws of the State of New York, having its principal place of business at 110 8th Street, J Building, Troy, NY 12180, is desirous of obtaining the entire right, title, and interest in, to and under the said improvements and the said application;

NOW, THEREFORE, for good and valuable consideration, the receipt and sufficiency of which are hereby acknowledged, we have sold, assigned, transferred and set over, and by these presents do hereby sell, assign, transfer and set over, unto the said Rensselaer Polytechnic Institute, its successors, legal representatives, and assigns the entire right, title, and interest in, to and under the said Invention entitled FILTRATION METHODS FOR DUAL-ENERGY X-RAY CT and any and all improvements thereto, and in and to the said application and any

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division, continuation, continuation-in-part thereof or renewal thereof, and in and to any and all

Letters Patent of the United States which may be issued on any said applications thereon, claim

priority therefrom, and any and all reissues, re-exams and extensions thereof, and in and to any

and all applications for Letters Patent filed in any country or countries foreign to the United

States for the said Invention or improvements, including all priority rights, and any and all

Letters Patent which may be granted in any country or countries foreign to the United States

therefor, and in and to any other applications based in whole or in part on any of the foregoing;

and we hereby authorize and request the Commissioner of Patents of the United States and any

Official of any country or countries foreign to the United States, whose duty it is to issue patents

on applications as aforesaid, to issue all Letters Patent for said improvement to the said

Rensselaer Polytechnic Institute, its successors, legal representatives and assigns, in accordance

with the terms of this instrument.

AND WE HEREBY represent, warrant and covenant that we have the full right and

power to make this assignment and that the rights, titles, and interests assigned are not

encumbered by any agent, license, or right heretofore given and that we have not executed, and

will not execute, any agreement in conflict herewith.

AND WE HEREBY further represent, warrant, covenant and agree that we will

communicate to said Rensselaer Polytechnic Institute, its successors, legal representatives and

assigns, any facts known to us respecting the said Invention and any and all improvements

thereto, and testify in any legal proceeding, sign all lawful papers, execute all divisional,

continuing and reissue applications, make all rightful oaths, and generally do everything possible

to aid said Rensselaer Polytechnic Institute, its successors, legal representatives and assigns to

obtain and enforce proper patent protection for said improvements in all countries.

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IN TESTIMONY WHEREOF, We hereunto set our hands and seals the day and year set opposite our signatures.

Date: 2-24-2021

Daniel David Harrison

Date: 2-24-21

Ge Wang

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